

碩士學位 請求論文

Laser 石造文化財
汚染物 除去 關 研究

- -

慶州大學校 大學院

文化財學科

金 振 亨

指導教授 韓 京 淳

2003年 7月

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論文 碩士學位 論文 提出

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金振亨 碩士學位論文 認准

委 員 長_____

審查委員_____

審查委員_____

慶州大學校大學院

2003年 7月

碩士學位 請求論文

[illegible]

•

1.

1)

1906 12 宮内大臣 田中光顯
1907 3 . 1907 3
6
(, 1996). 1919
1959 1960 建春門
1995 .
' ,
<至正八年戊子三月 日()>
가 29 4 (1348) .
,
.
.
(2)
,
가 가
3 가 (亞)
基底 . 3
, 가 3
,
.
, ,
.

가 14 (, 1998).

2)

1919 가 1960 (, 1996). 1960 , 가 (, 2003).

SO₂, NO₂, O₃ , 가 , 가 (, 1997). , 가 SO₂, NO_x HC (, 1988). SO₂ , (EPA, 1969), (, 1980).

1996 1 1997 6 () 가

7.7 1.2 가 . , (, 1997),

， ， 酸

．

， (2)

．

가 , 1993

， 가

가

(, 1993) 가

가 1999 12

(3)

가

1995 6

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3)

(24)

1923

가 1934

(steam cleaning)

1941

1947 , 1953 , 1957

5

,
 .
 1953 , 1954 6
 4
 . 1957 9
 .
 1958 1 14
 가 가 , 가
 가
 .
 1967 『 』
 1963 3 .
 1970 9 , , , ,
 , ,
 ,
 .
 가 (, 1970, 1971).
 1977
 가
 ,
 가 . 前
 ,
 가 . 90
 (Table 1).

Table 1.

195		1977
194	, ,	1980
10		1980
197		1981
33 가		1983
37		1983
87		1983
73		1983
137		1984
581		1985
846		1985
7		1986
581		1986
386		1986
395		1986
59		1987

12		1988
830	, , ,	1988
465		1988
43		1988
2 19		1988
84		1989
45		1989
2 19		1989
64		1989
679		1991
111		1991
122		1992
53 4		1992
53	가	1992
54	〃	〃
151	〃	〃

152	〃	〃
153	〃	〃
154	〃	〃
981		1993
116		1993
136		1994
432		1995
112 ()		1996
39		1996
200		1996
297		1996
126		1996
674		1996
387	, 가 ,	1997
139		1997
658		1998
39		1998

112 ()		1998
132		1999
187		2000
139		2000
312		2001
35		2001
84		2001
54		2001
84	,	2001
97		2001
242	()	2001

: (1977~2002)

,
 , (Blasting)
 , ,
 (, 1998).

2mm
 가
 가

가 .

가 가
(, 2002).

()

가

(, 2001).

, , ,

.

.

, ,

가 .

.

,

(Hydrated phyllosilicat-

es)

1~2

,

(, 1998).

mm

μm

가 (, 2001).

가 .

Arthur Schwlow

(laser eraser)'

, 1972 John Asmus

가

가

가

(Asmus

, J. F., 1987, 1999).

Victoria & Albert

2

1970

가 . 1990

가

가

(micro- abrasive)

(chemical flux)

.

1.

1)

가 (Optical Microscope, Carl Zeiss, AxioTech/Progress 30 12, Germany) .
50X .

X-
X-
(Micro-area X-ray diffraction system, MAC Science, MXP 18VA, Japan) . X-
Target Cu . (peak matching)

’
X . XRD Rigaku RINT 2200 X
, 40kV/30mA CuK_α .

X- (EDXRF)
가 chamber ,
5 , 20
kV, 0.5mA, 300micro collimator , Vacuum
100sec .

(ICP - AES)

50mg 100Mℓ
(HNO₃) (HF) 5Mℓ 가 가 200℃
. (HNO₃) 3Mℓ +
(HClO₄) 5Mℓ 가 가 가
, 100g .
(SPS 1500R, Japan) ,
1.3 kW, 가 18 ℓ /min, 가 0.5 ℓ /min, 가 1.0 ℓ
/min, 12.4mm , K, Na 1.7kW .

SEM(Scanning Electron
Microscope, Jeol, JSM- 5910LV, Japan) ,
EDS(Energy Dispersive Spectroscope, Oxford 7324,
England) , 20kV, spotsize 50
. mapping

2.

1)

가 ,
(Maiman)
. ()
.
,
(spontaneous emission) ,

.
 가
 , (),
 .
 (stimulated emission) , .
 가
 ,
 . ,
 . ,
 .
 (light amplification) ,
 .
 , .
 (694nm)
 Nd:YAG (1064nm), (780- 1600nm) ,
 (CO₂) (10.6 μ m), (excimer) (
) He - Ne (633nm) ,
 (300- 1000nm)가 .

(Monochromaticity),
 (Coherence), (Directionality) 가 .
 .
 , (Chromatic aberration)
 (W/cm²)
 (位相) ,
 ,

가
1m
가
100m
가

가
가가
가 (Figure 1).

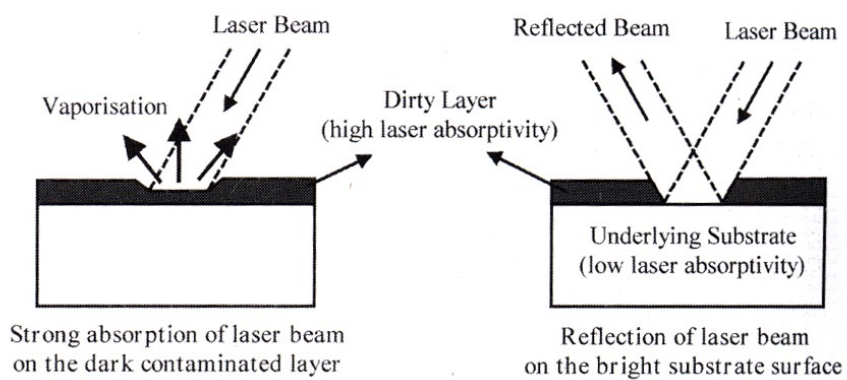


Figure 1.

가 가
가 가
가
가

YAG 가 , 가
가 5mm, 0.5~2J/cm² 20
가
가

1)
2), 3)
4)
40mm×40mm
×20mm

Q-Switched Nd-YAG(Neodymium-Yttrium Aluminum Garnet) Laser(Light Amplification by Stimulated Emission of Radiation) (日本赤外線株式會社, Japan).
(Output Wavelength): 1064nm, (Energy Output):

1 , , , (packstone)
limemud(0.004mm)
2
, -
0.1 2.5mm
3 ,
가
4 , 가
, 가

0-300mJ, (Repetition Rates): 1-10Hz, (Pulse Duration): 6ns .

(Absorptivity)

가
가 .

(Monochromaticity)

,
4가 ,
(色)
(鐵
片)
,
,
4가
.
.
色 .

, (chromatic aberration)
() 가
(W/cm²)

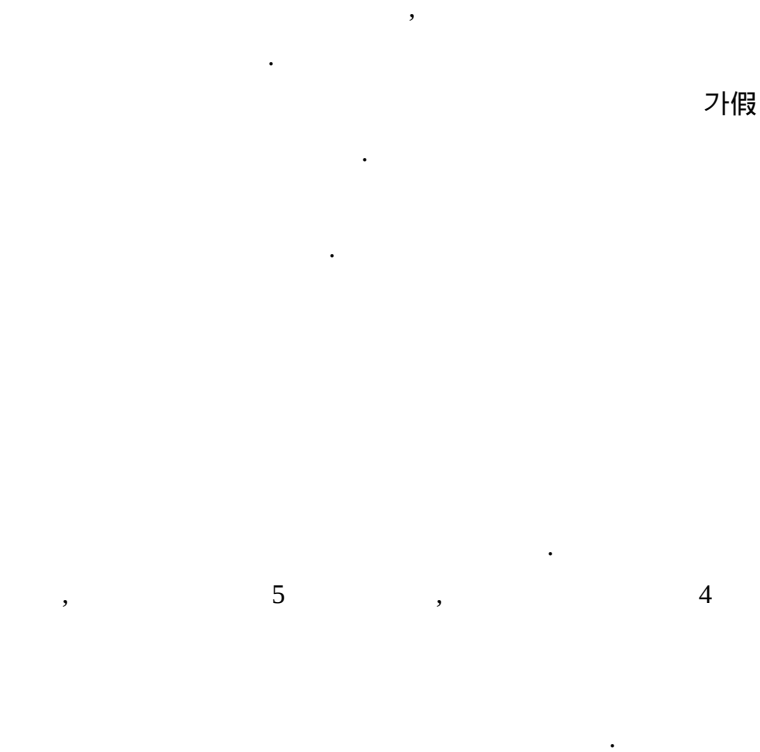
.

. 가假 ()

10mm

10

.



2)

(Figure 2).

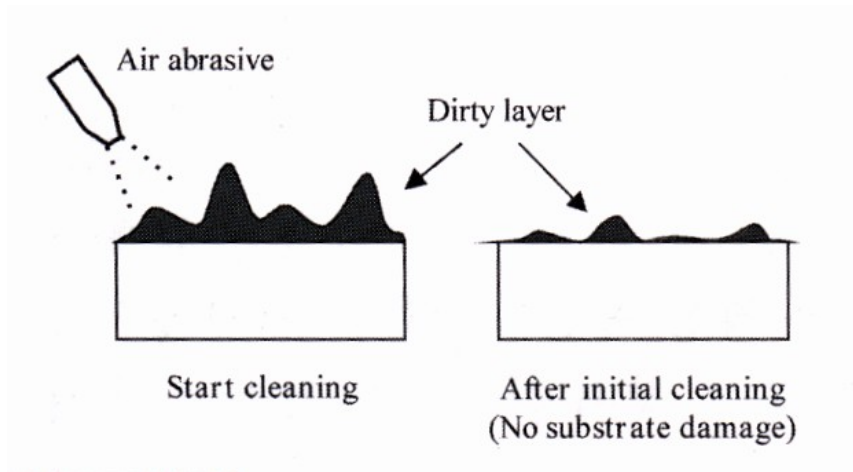


Figure 2.

shape : spherical
 colour : transparent, white
 hardness : rockwell C 46
 : Mohs 6 - 7
 specific density : 2.5 kgs/dm³
 loose bulk density : 1.5 kgs/dm³

SiO ₂	: min.	65.0%
Na ₂ O	: min.	14.0%
CaO	: min.	8.0%
MgO	: min.	2.5%
Al ₂ O ₃		2.0%
Fe ₂ O ₃	: max.	0.15%
Other	: max.	2.0%

가

가

1 ~ 50 micron	150 ~ 250 micron
40~ 70 micron	200 ~ 300 micron
50 ~ 105 micron	200 ~ 400 micron
70 ~ 110 micron	300 ~ 400 micron
90 ~ 150 micron	400 ~ 600 micron
100 ~ 200 micron	400 ~ 800 micron

40mm×40mm×20mm

Sand Blaster(IBIX, Norway)

2~7 bars

250Liters/min

Plastic

1.4mm(Ø)

2~3cm

50cm

4bars

가

가

가

.

1.

1)

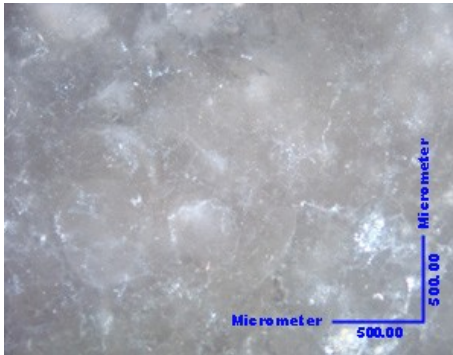


Photo 4. - - 5X

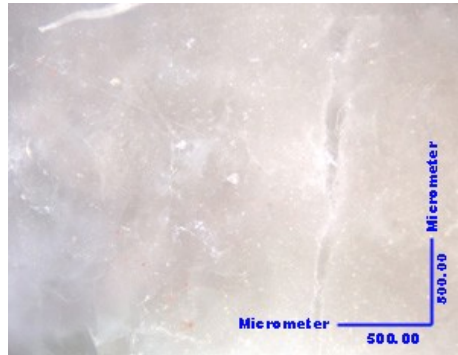


Photo 5. - - 5X

,

,

가

,

가

.

2) X

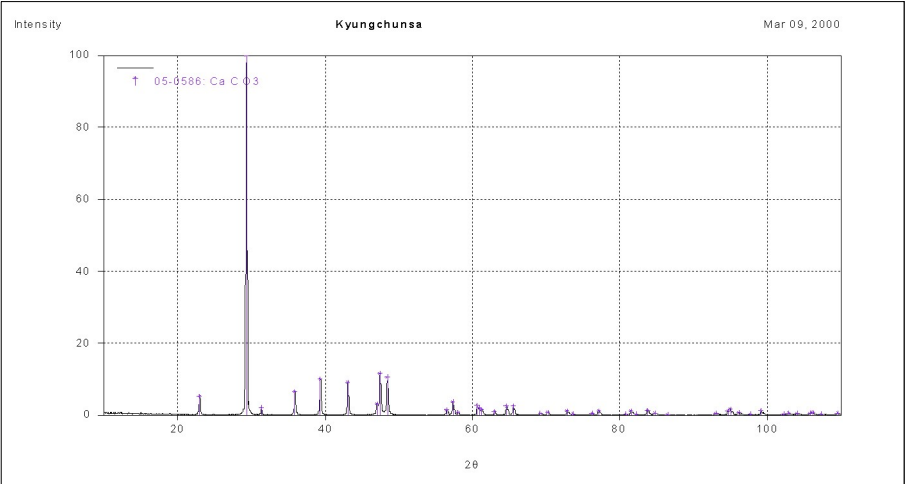


Figure 3. XRD - No. 1(Calcite)

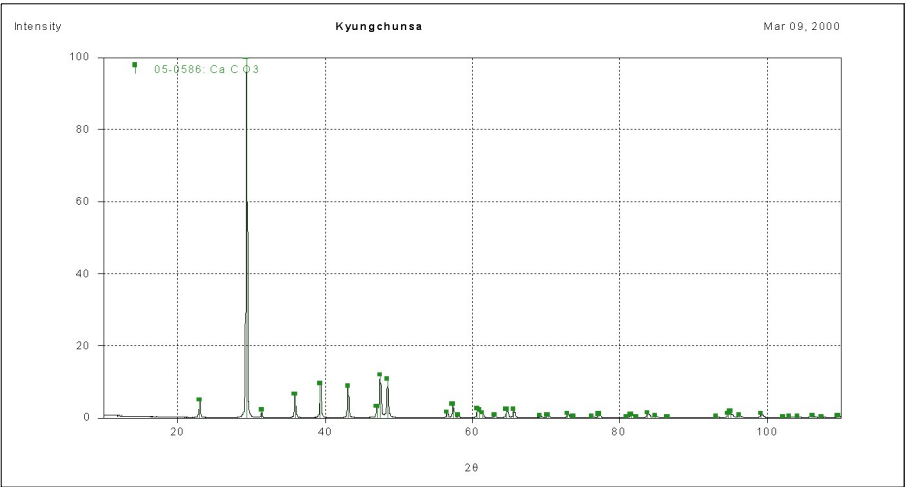
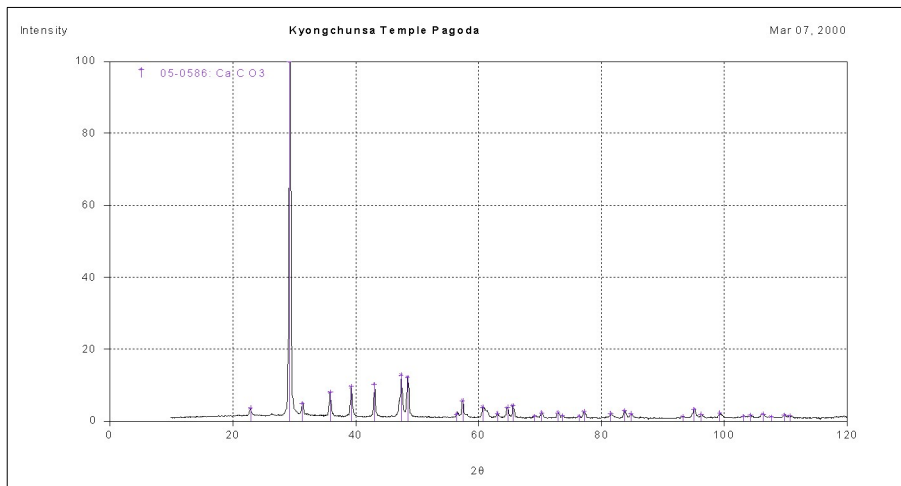
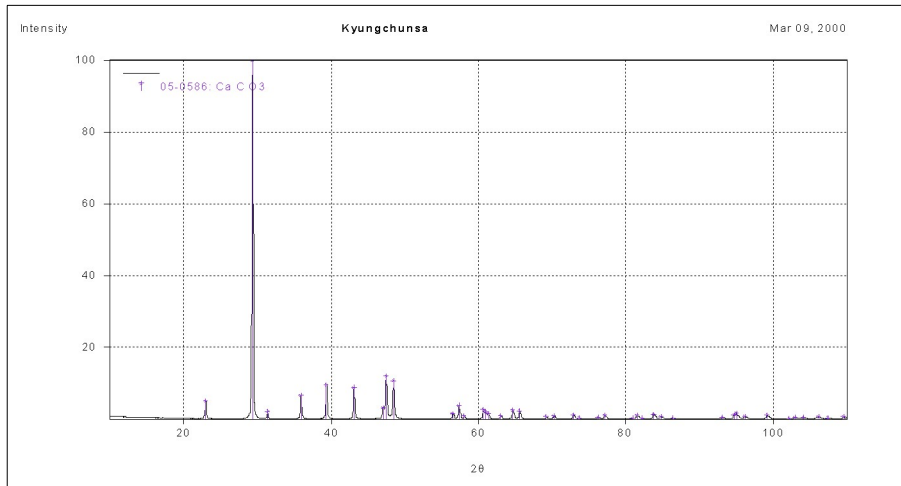


Figure 4. XRD - No. 2(Calcite)



Angle XRD (Figure 3, 4, 5)

Calcite (Figure 6)

Micro Area XRD

Wide Angle XRD

3)

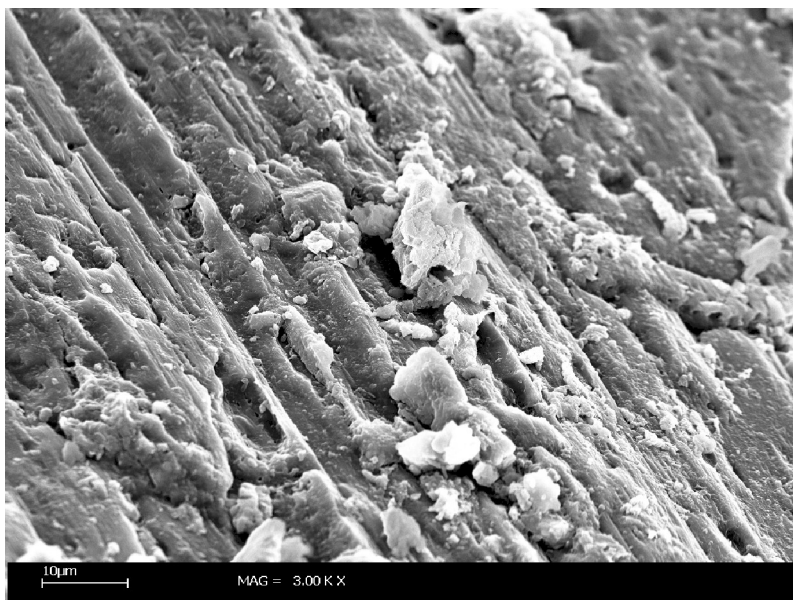


Photo 1.

(3,000)

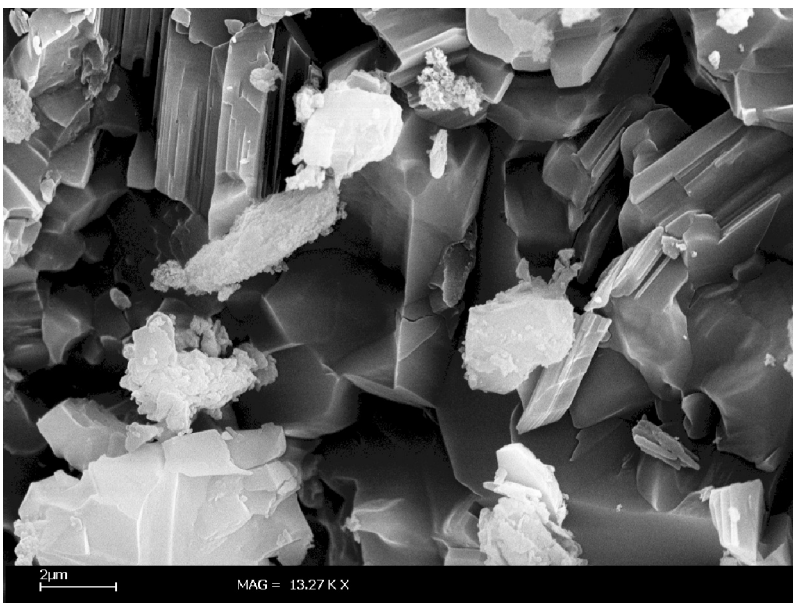


Photo 2.

(13,270)

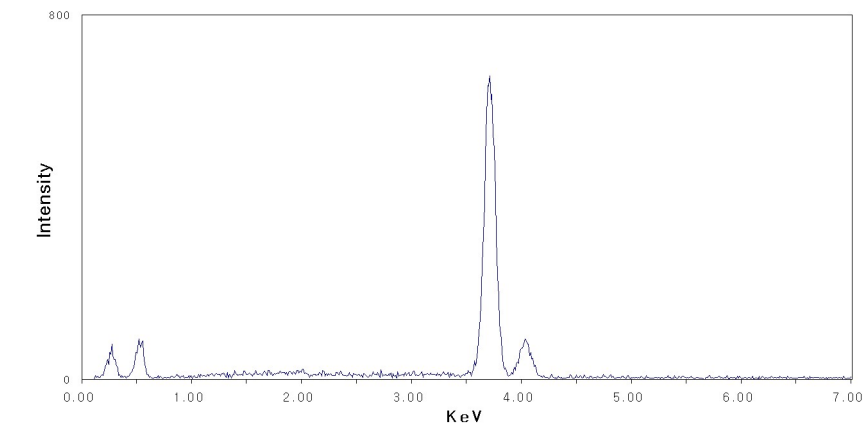


Figure 7.

EDX

Photo 1, 2

, EDX (Figure 7) Ca가
(Calcite, CaCO_3) .

2.

1)

. (Table 4)

.
가 .

가

.

,

.

가

.

.

.

(Photo 3).

2

가

.

.

가 가

,

,

가

.

Photo 3

,

가

.



Photo 3. (3)

Table 2.

A		가 ()
B		가 1mm
C		가 1mm

D		
---	---	--

Table 3.

	1	2	3	4	5		
10mmX10mm	100mm ²	200mm ²	300mm ²	400mm ²	500mm ²		

※ : 가

Table 4.

1	()	X	-	-	A type
2	()	X	-	-	
3	()	X	-	-	
4	()	X	-	-	
5	()	X	-	-	
6	()	X	-	-	
7	()	X	-	-	
8	()	X	-	-	
9	()	O	C	2	A type
10	()	O	D	1	
11	()	O	B	8	
12	()	O	B	10	
13	()	O	B	8	
14	()	O	C	8	
15	()	O	C	4	
16	()	O	C	1	
17	()	X	-	-	A type
18	()	X	-	-	
19	()	O	D	1	
20	()	X	-	-	
21	()	X	-	-	
22	()	X	-	-	
23	()	O	D	2	
24	()	X	-	-	
25	()	O	C	10	A type
26	()	O	C	3	
27	()	O	B	16	
28	()	O	C	5	
29	()	O	B	7	
30	()	O	B	5	
31	()	O	B	14	
32	()	O	B	3	
33	()	O	D	3	A type
34	()	X	-	-	
35	()	O	D	1	
36	()	X	-	-	
37	()	O	D	2	
38	()	X	-	-	
39	()	O	D	2	

40		()	X	-	-	A
41		()	O	B	1	A type
42		()	O	B	2	
43		()	O	B	1	
44		()	O	B	4	
45		()	O	C	3	
46		()	O	C	4	
47		()	O	B	3	
48		()	O	B	2	
49	1	()	O	C	5	A type
50	1	()	X	-	-	
51	1	()	O	C	8	
52	1	()	X	-	-	
53	1	()	O	B	15	
54	1	()	O	B	5	
55	1	()	O	B	8	
56	1	()	O	B	8	
57	1	()	O	B	8	A type
58	1	()	O	C	8	
59	1	()	O	C	10	
60	1	()	O	C	6	
61	1	()	O	B	12	
62	1	()	O	C	14	
63	1	()	O	C	8	
64	1	()	O	B	10	
65	1	()	O	B	20	A type
66	1	()	O	B	10	
67	1	()	O	B	20	
68	1	()	O	B	10	
69	1	()	O	B	20	
70	1	()	O	B	10	
71	1	()	O	B	20	
72	1	()	O	B	10	
73	2	()	O	B	16	A type
74	2	()	O	B	6	
75	2	()	O	B	3	
76	2	()	O	B	5	
77	2	()	O	B	5	
78	2	()	O	B	3	
79	2	()	O	B	15	A type
80	2	()	O	B	5	
81	2	()	O	B	10	

82	2	()	O	B	2	A type
83	2	()	O	B	8	
84	2	()	O	B	6	
85	2	()	O	B	8	
86	2	()	O	B	6	
87	2	()	O	B	25	A type
88	2	()	O	B	10	
89	2	()	O	B	25	
90	2	()	O	B	10	
91	2	()	O	B	25	
92	2	()	O	B	10	
93	2	()	O	B	25	
94	2	()	O	B	10	
95	3	()	O	B	10	B type
96	3	()	O	B	8	
97	3	()	O	B	10	
98	3	()	O	B	7	
99	3	()	O	A	8	A type
100	3	()	O	A	2	
101	3	()	O	A	5	
102	3	()	O	B	8	
103	3	()	O	B	5	
104	3	()	O	B	5	
105	3	()	O	B	8	
106	3	()	O	B	6	
107	3	下()	O	A	25	A type
108	3	下()	O	A	5	
109	3	下()	O	B	32	
110	3	下()	O	A	5	
111	3	下()	O	B	32	
112	3	下()	O	B	5	
113	3	下()	O	B	32	
114	3	下()	O	B	5	
115	3	上()	O	B	7	B type
116	3	上()	O	B	7	
117	3	上()	O	B	8	
118	3	上()	O	B	8	
119	4	()	X	-	-	B type
120	4	()	X	-	-	
121	4	()	O	B	3	
122	4	()	X	-	-	

123	4	()	O	B	20	B type
124	4	()	O	B	10	
125	4	()	O	B	15	
126	4	()	O	B	5	
127	4	()	X	-	-	B type
128	4	()	O	B	10	
129	4	()	O	B	20	
130	4	()	O	B	10	
131	5	()	X	-	-	B type
132	5	()	X	-	-	
133	5	()	X	-	-	
134	5	()	X	-	-	
135	5	()	O	B	5	B type
136	5	()	O	B	3	
137	5	()	O	B	5	
138	5	()	O	B	3	
139	5	()	O	B	15	B type
140	5	()	O	B	15	
141	5	()	O	B	15	
142	5	()	O	B	15	
143	6	()	O	C	3	B type
144	6	()	X	-	-	
145	6	()	O	B	5	
146	6	()	X	-	-	
147	6	()	O	A	5	B type
148	6	()	O	B	8	
149	6	()	O	B	10	
150	6	()	O	B	5	
151	6	()	O	B	15	B type
152	6	()	O	B	15	
153	6	()	O	B	15	
154	6	()	O	B	15	
155	7	()	O	C	1	B type
156	7	()	O	B	2	
157	7	()	O	B	3	
158	7	()	O	C	1	
159	7	()	O	B	3	B type
160	7	()	O	B	3	
161	7	()	O	C	3	
162	7	()	O	B	3	
163	7	()	O	B	15	

164	7	()	O	B	15	B type
165	7	()	O	B	15	
166	7	()	O	B	15	
167	8	()	O	B	3	B type
168	8	()	X	-	-	
169	8	()	O	B	3	
170	8	()	X	-	-	B type
171	8	()	O	B	3	
172	8	()	O	B	2	
173	8	()	O	C	3	
174	8	()	O	B	1	B type
175	8	()	O	C	10	
176	8	()	O	B	10	
177	8	()	O	C	10	
178	8	()	O	B	10	B type
179	9	()	O	B	1	
180	9	()	O	B	1	
181	9	()	O	B	3	
182	9	()	X	-	-	B type
183	9	()	O	B	5	
184	9	()	O	C	2	
185	9	()	O	C	5	
186	9	()	O	B	2	B type
187	9	()	O	B	10	
188	9	()	O	C	10	
189	9	()	O	C	10	
190	9	()	O	B	10	B type
191	10	()	O	A	3	
192	10	()	O	B	1	
193	10	()	O	B	3	
194	10	()	O	B	1	B type
195	10	()	O	B	2	
196	10	()	O	B	3	
197	10	()	O	C	3	
198	10	()	X	-	-	B type
199	10	()	O	B	10	
200	10	()	O	B	12	
201	10	()	O	B	12	
202	10	()	O	B	10	B type

※ A-type: , B-type:

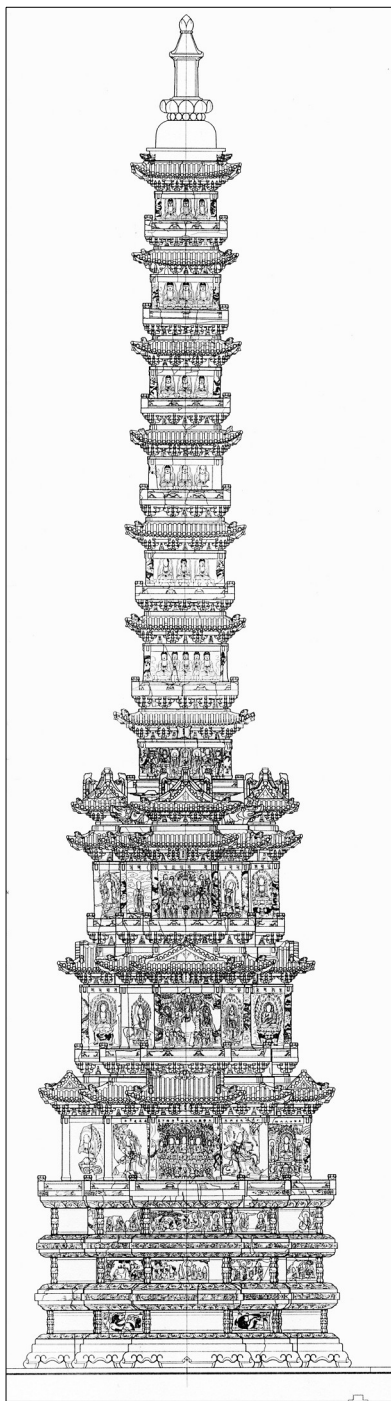


Photo 4.

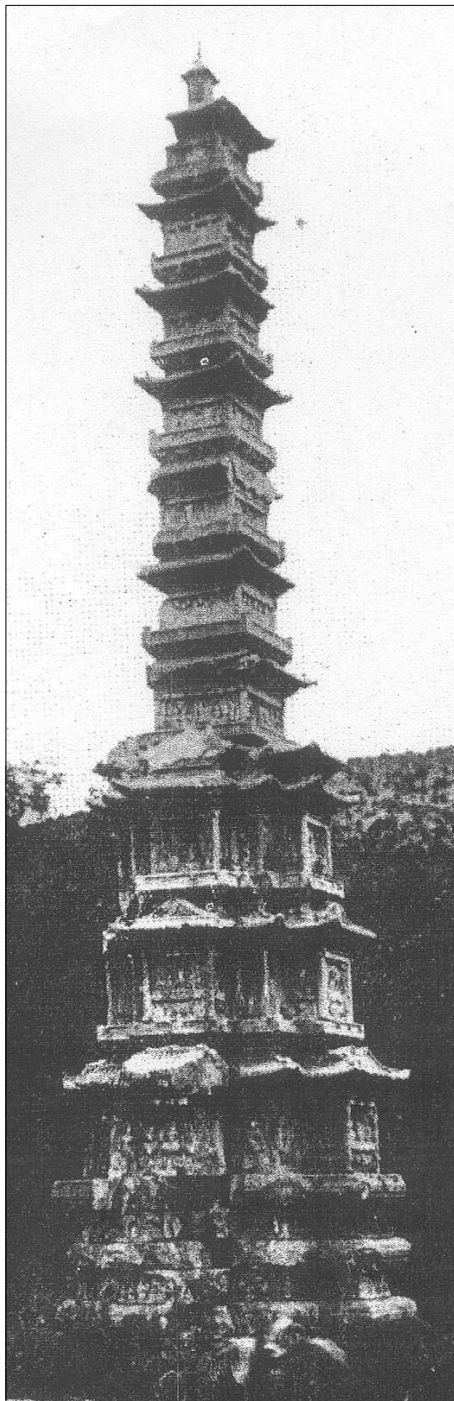


Photo 5. 1902

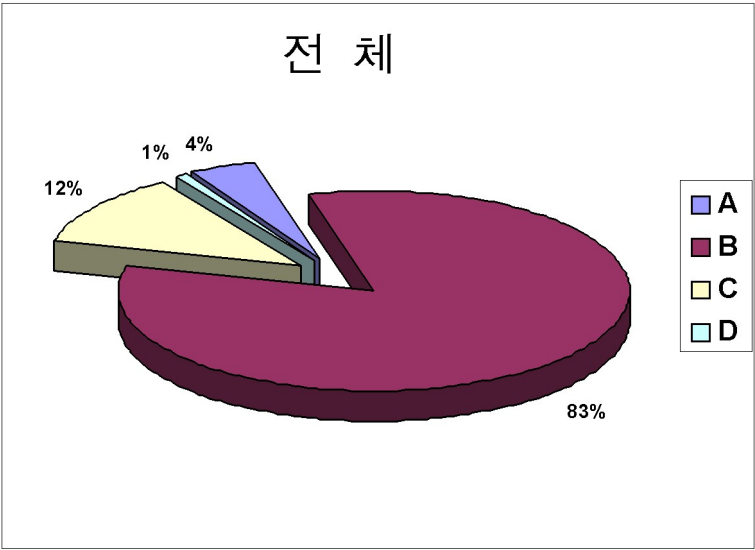


Figure 8 .

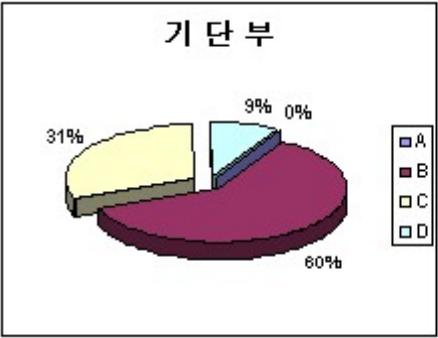


Figure 9.

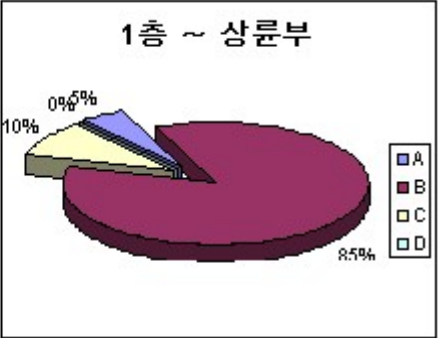


Figure 10.

()

(1 ~)

Figure

8~ 10

Figure 8

B(83%) C(12%) A(4%) D(1%)

B

(1 ~

)

B(60%) C(31%) D(9%)

A(0%),

(1 ~

)

B(85%)

C(10%)

A(5%)

D(0%)

$$[(A+B):(C+D)=60:40]$$

$$[(A+B):(C+D)=90:10]$$

가 .

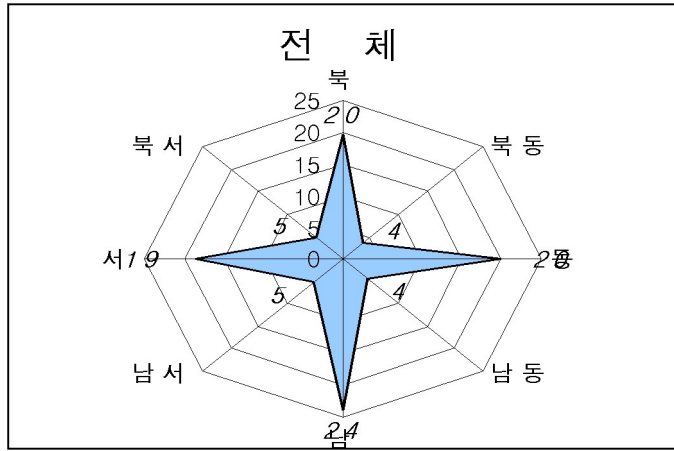


Figure 11.

()

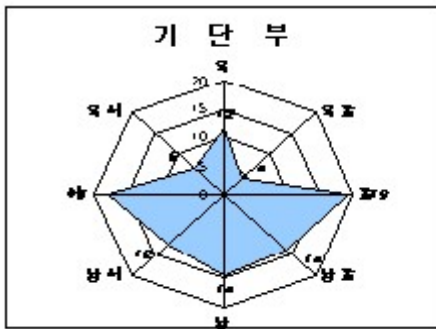


Figure 12.

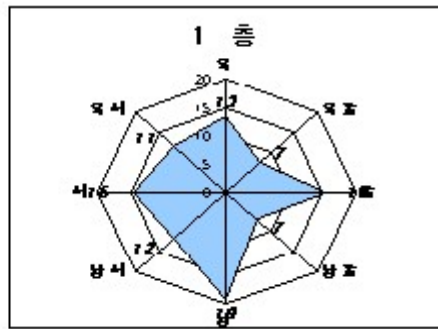


Figure 13. 1

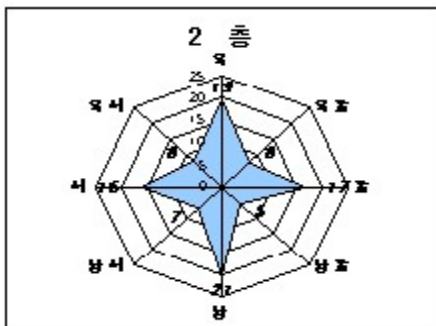


Figure 14. 2

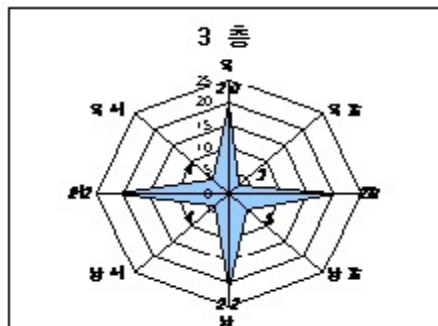


Figure 15. 3

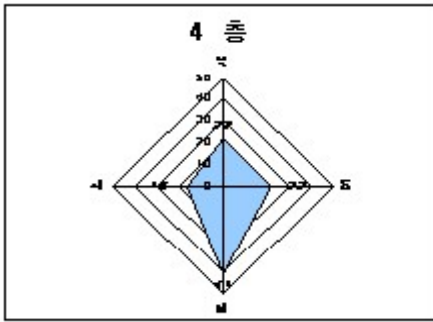


Figure 16. 4

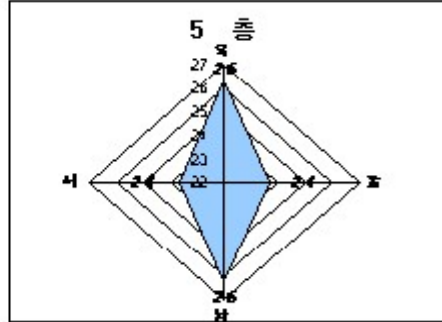


Figure 17. 5

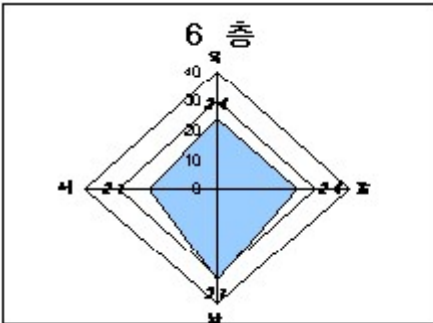


Figure 18. 6

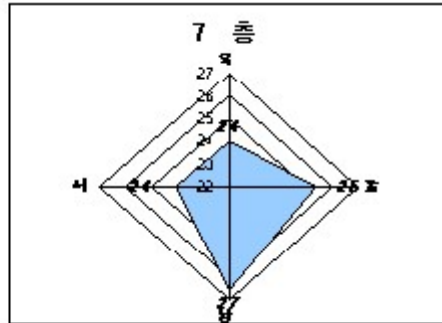


Figure 19. 7

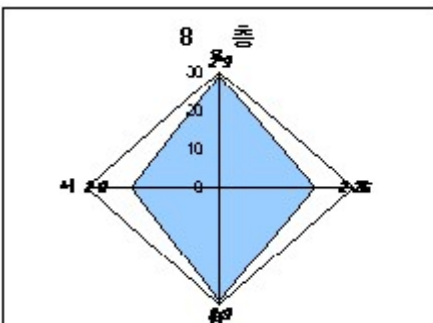


Figure 20. 8

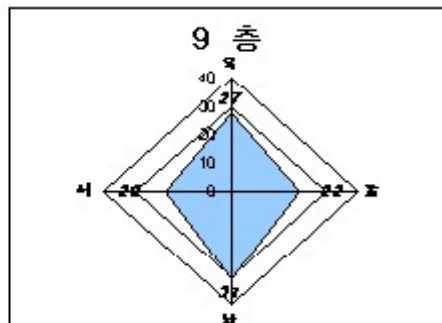


Figure 21. 9

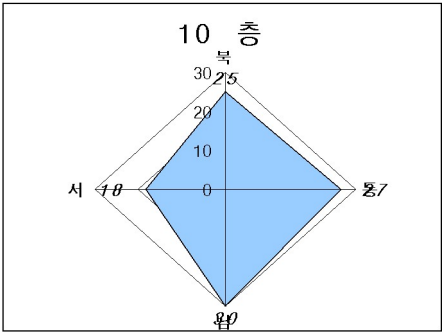


Figure 22. 10

Figure 11 , 24% 가 ,
 20%, 19%
 5%, 4% .
 , 8 가 ~3
 → → , 1 → → , 2
 3 . . . 4 가
 4 ~ 10 (31%) (25%) (24%) (20%) ,
 4 41% 가
 , 5 7 .



Figure 23. A

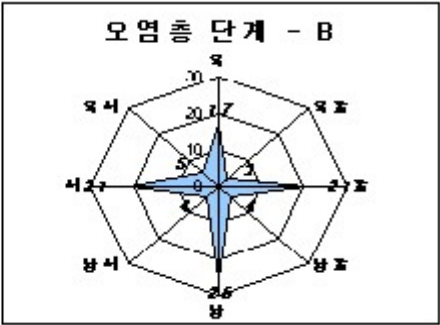


Figure 24. B

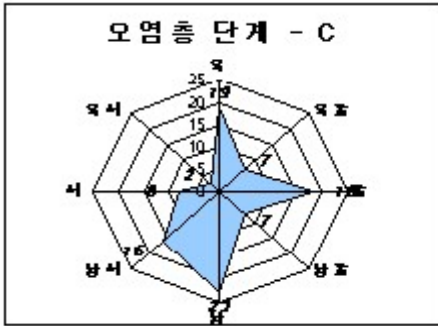


Figure 25. C



Figure 26. D

Figure 23~26 , 가

A (71%) (12%) =

(9%) , → → A 가 .

B

(25%) = (21%) (17%) 84% ,

4 ~ 10 4 가

가 . 가 C

(23%) (19%) (18%) (16%),

D (33%) (25%) = (17%) .

,

B 가 83% , 가

. 가 가 A

, 71% .

가 ,

가 .

2)

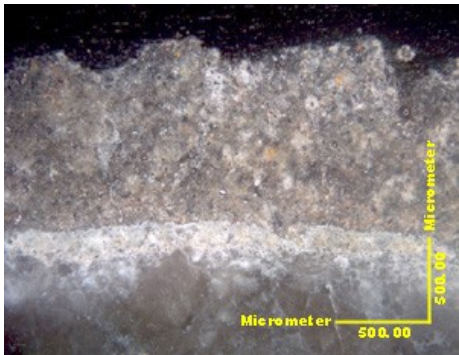


Photo 6. - - 5X

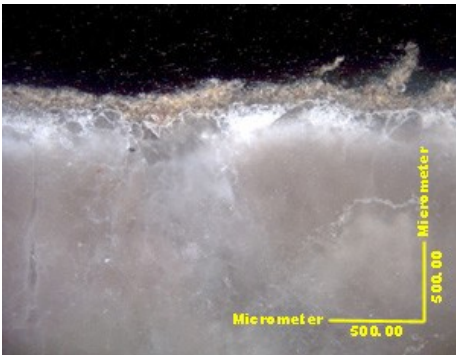


Photo 7. - - 5X

SEM-EDX

photo 6

photo 7

100 μ m

100 μ m,

600 μ m

가

X

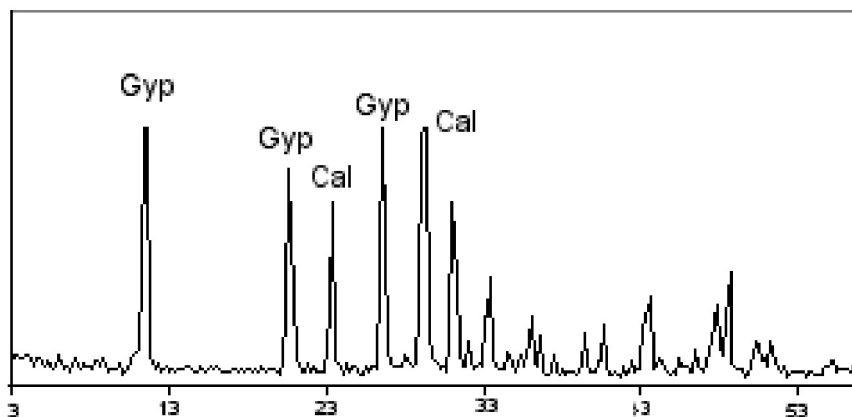


Figure 27. XRD Pattern -

XRD
(Gypsum)

(Calcite)

X (EDXRF)

Figure 28~33

X-

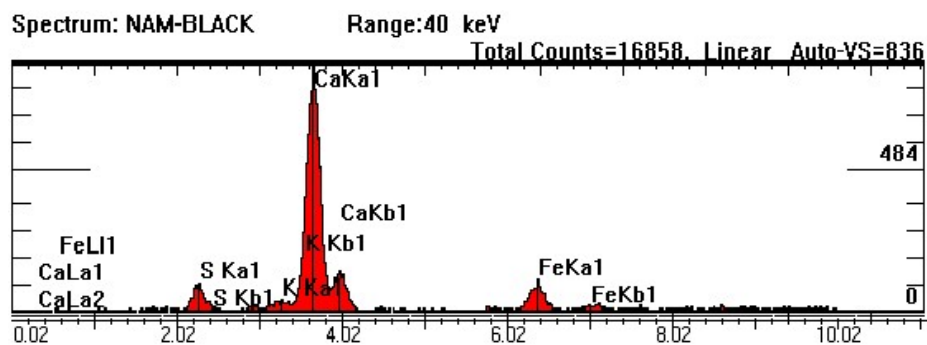


Figure 28. - - Ca, Fe, S, K

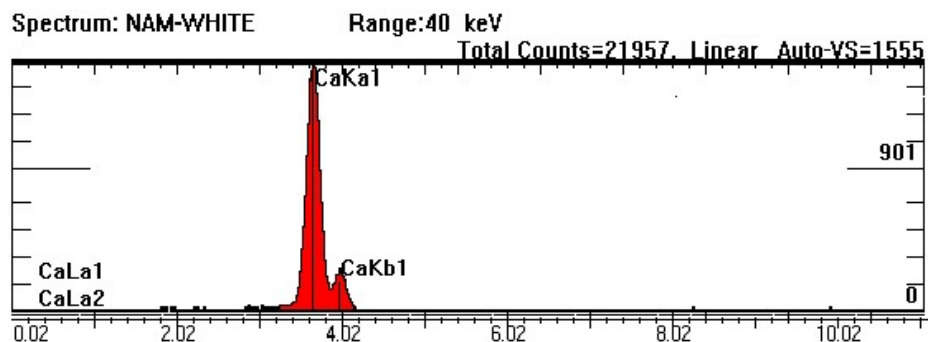


Figure 29. - () - Ca

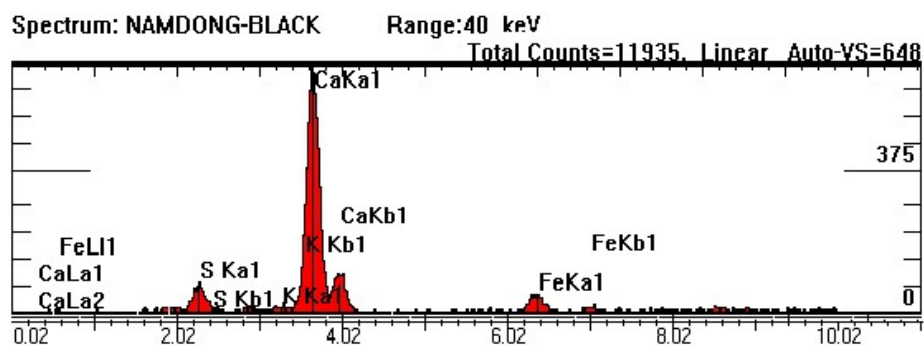


Figure 30. - - Ca, Fe, S, K

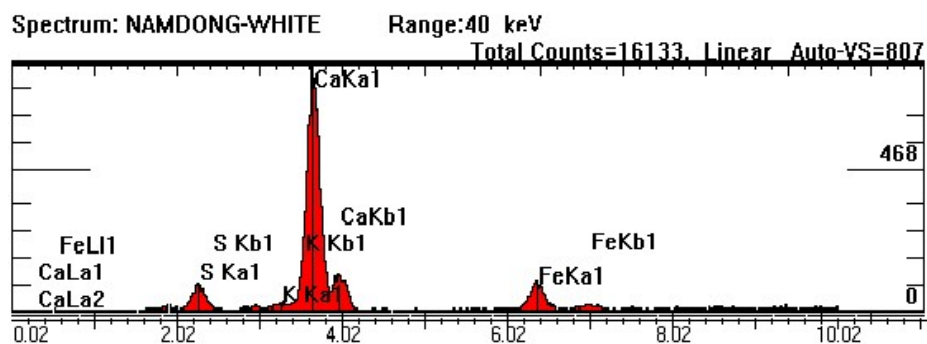


Figure 31. - - Ca, Fe, S, K

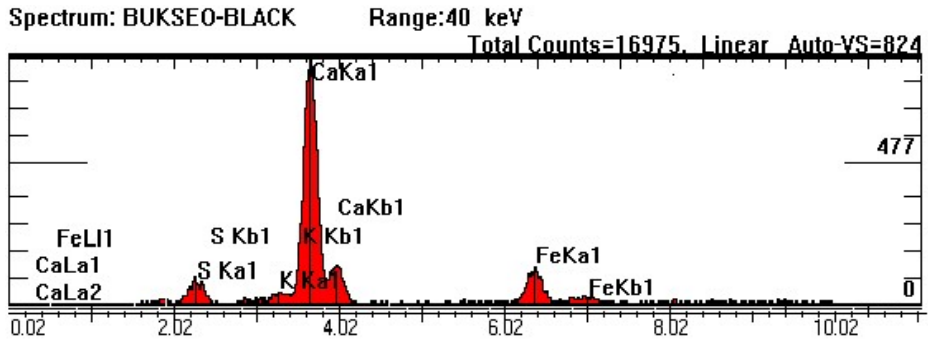


Figure 32. - - Ca, Fe, S, K

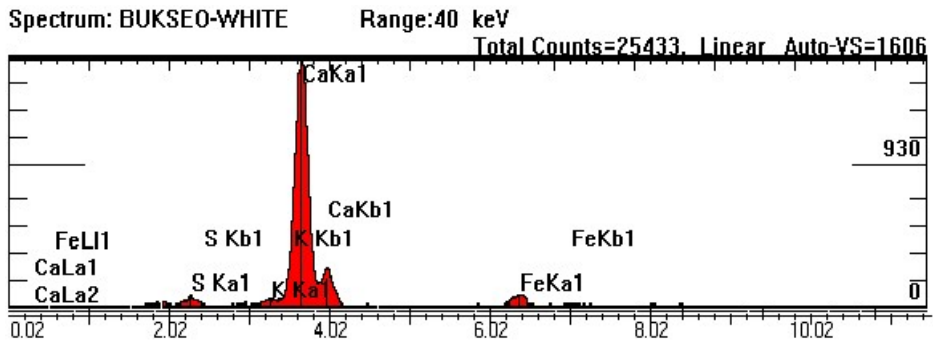


Figure 33. - - Ca, Fe, S, K

X Ca, Fe, S
K peak가 . Ca
, Fe, K S .
Ca, Fe S가
K peak , .
Ca , Fe,
K, S .
Ca, Fe, S , K
peak가 , .
Ca , Fe, K, S .
, , Ca,
Fe, S, K peak가 , Ca

, K , Fe S .
Ca가 ,

(ICP - AES)
ICP Table 5
Ca가 19~20wt% , 2
15wt% . Al Fe, K
0.3~0.8wt% .
가
SEM-EDX

Table 5.

	2	2	2	2	2
Ca	19.3	20.3	19.8	15.2	20.1
Al	1.80	1.02	1.27	0.84	1.07
Fe	0.79	0.48	0.59	0.36	0.49
K	0.57	0.27	0.36	0.31	0.30
Na	0.29	0.17	0.21	0.17	0.18
Mg	0.33	0.17	0.22	0.10	0.11
Mn	0.011	0.007	0.009	0.005	0.008
Zn	0.010	0.008	0.017	0.007	0.011
Cu	0.011	0.018	0.008	0.007	0.010
Ti	0.068	0.043	0.050	0.036	0.040
	23.18	22.486	22.534	17.035	22.319

: wt%

(SEM- EDX)

SEM- EDX
Photo 8, 9 (Gypsum)
EDX (Figure 34)
(Table 6) Ca, S, K가
Si Al . Ca Calcite $\text{CaSO}_4 \cdot 2\text{H}_2\text{O}$ (Gypsum)
, S $\text{CaSO}_4 \cdot 2\text{H}_2\text{O}$, K, Si, Al
(Albite)
mapping
(Figure 35~38), Al, Si, S, C

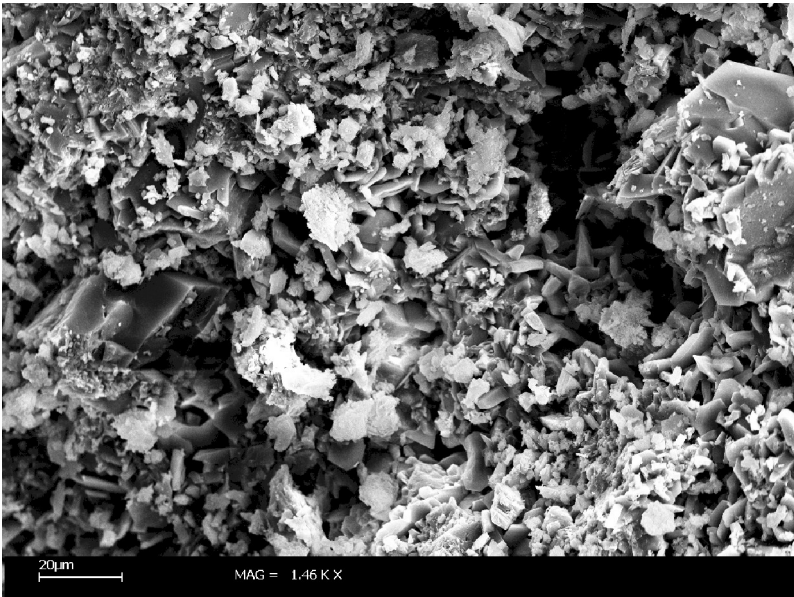


Photo 8. (1,000)

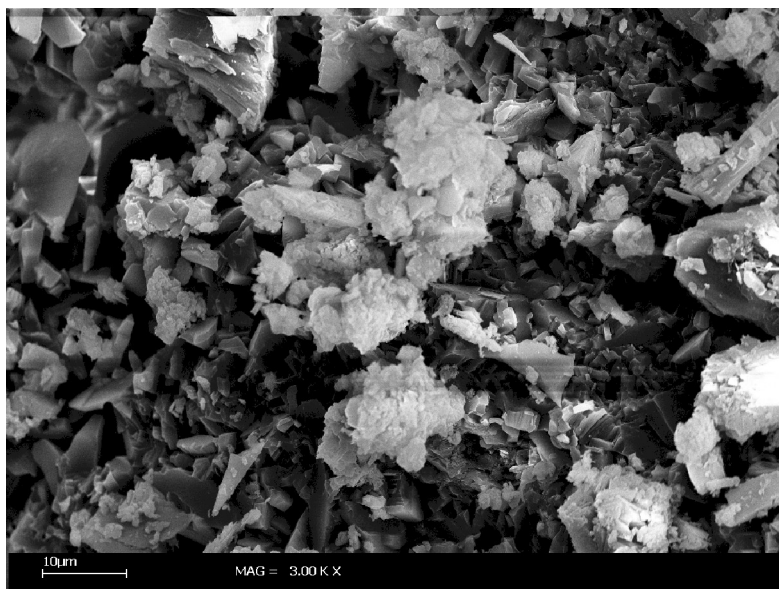


Photo 9. (3,000 X)

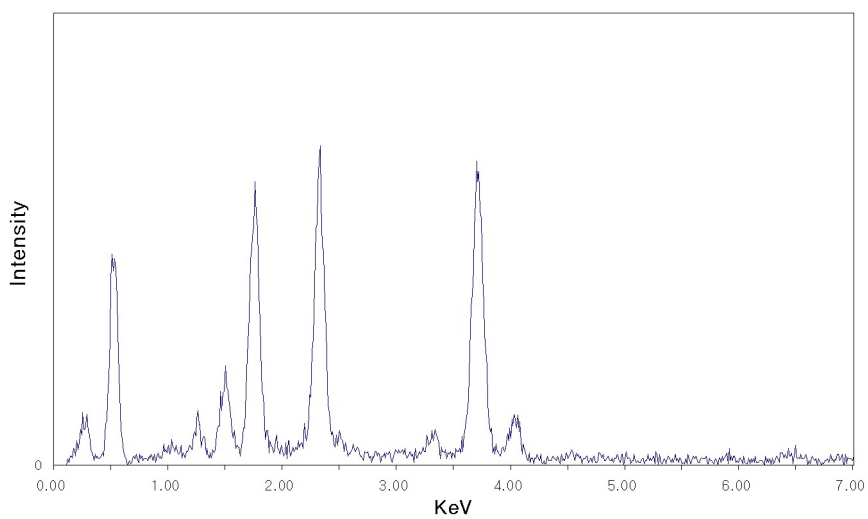


Figure 34. EDX

Table 6.

EDX

Element	Element Wt.%
Al	2.90
Si	8.06
S	29.18
K	29.77
Ca	30.08
Total	100.00

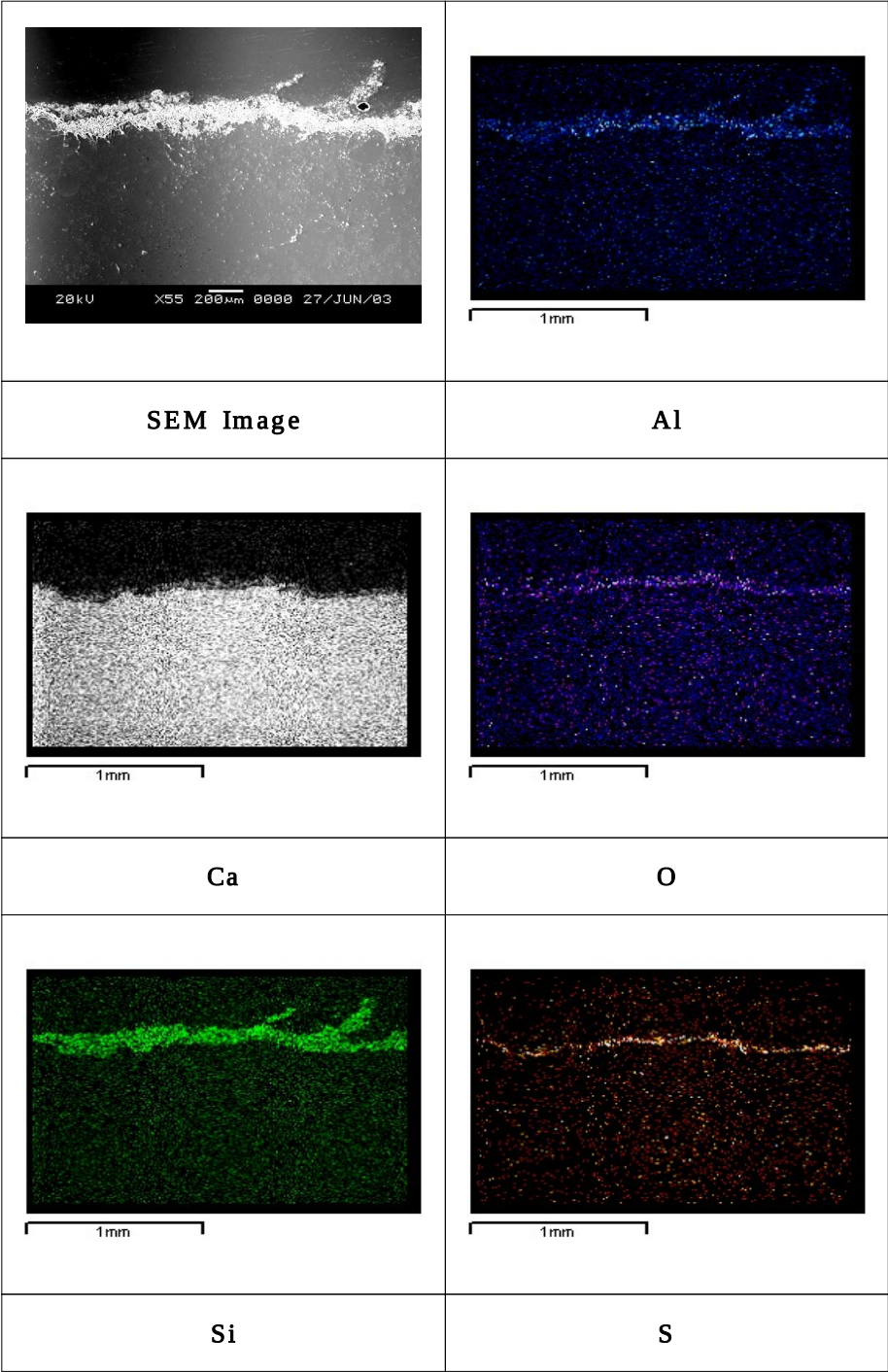


Figure 35.

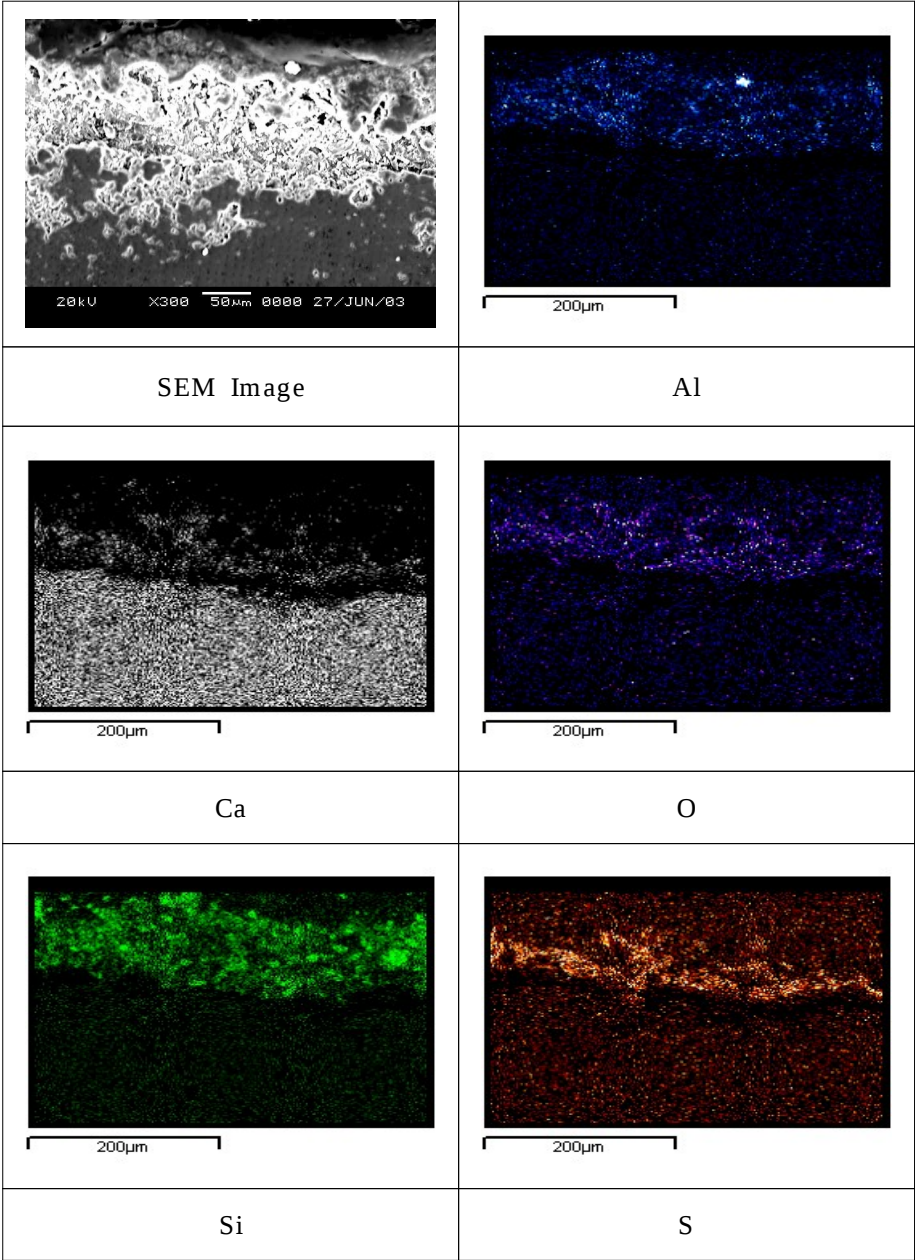


Figure 36.

- 300 - SEM-EDX mapping

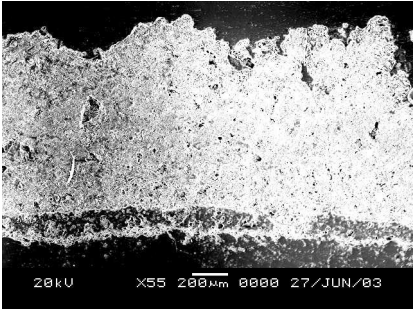
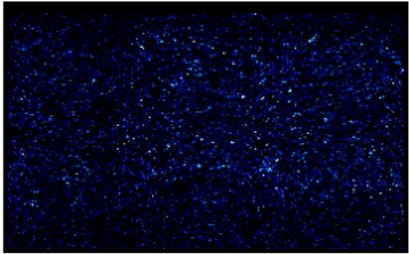
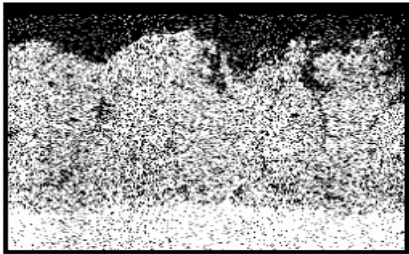
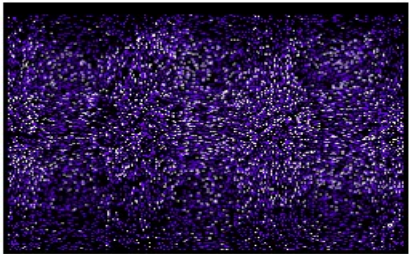
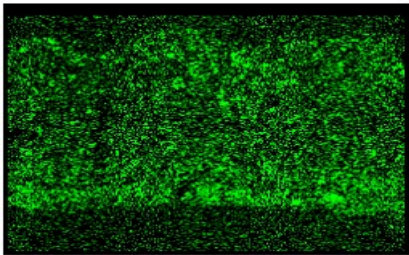
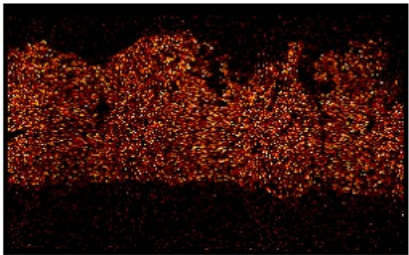
	
SEM Image	Al
	
Ca	O
	
Si	S

Figure 37.

- 55 - SEM-EDX mapping

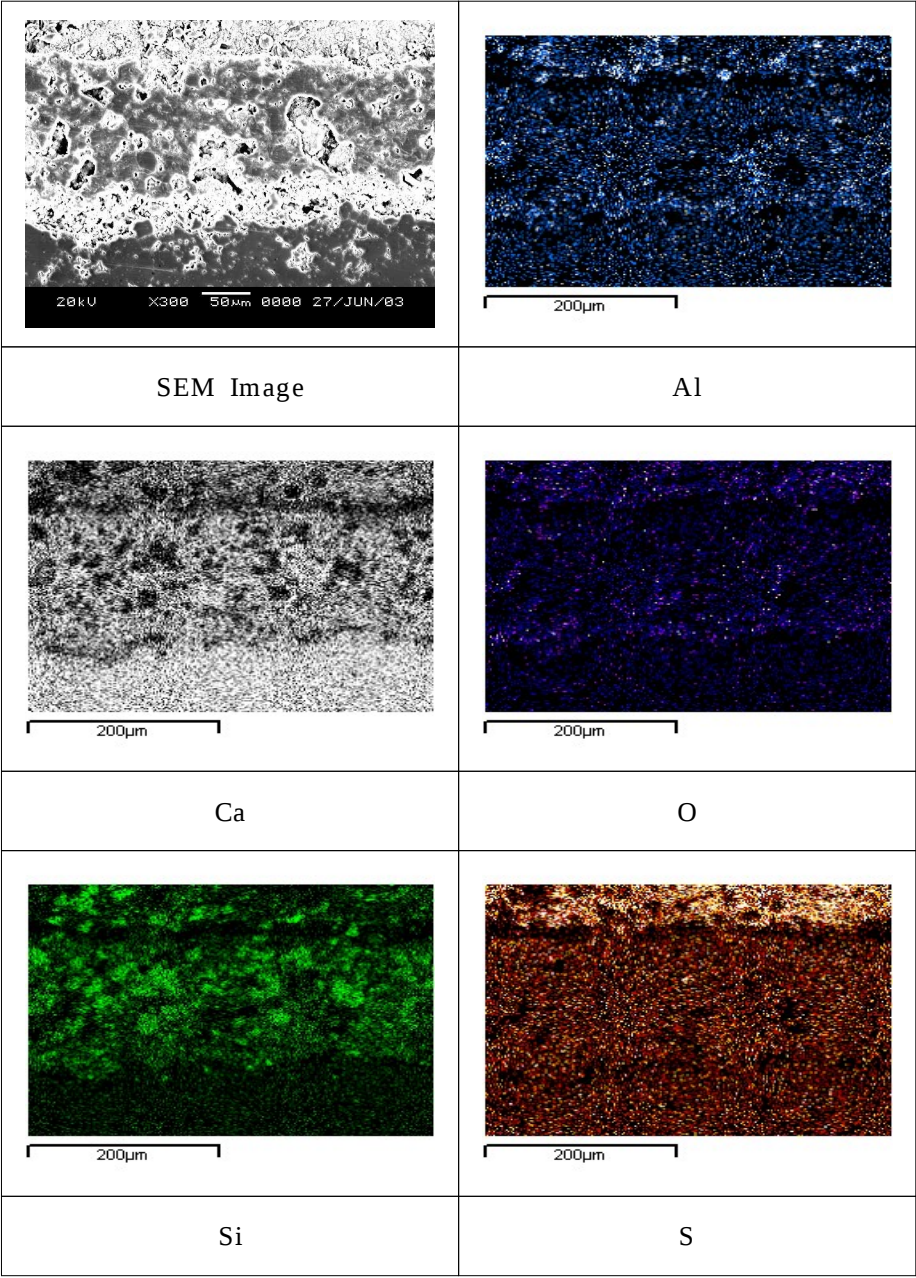


Figure 38.

- 300 - SEM-EDX mapping

3.

1)

， ， 4가 ，
， (鐵片) ，
，
．

色 Table 7 ．

Table 7. (○ - ● -)

	1	2	3	4	5	6	7	8	9
	○	●							
	○	○	○	○	○	●			
	○	○	○	○	○	○	●		
	○	○	○	○	○	○	○	○	●

POWER 0.45) Q-SW⁶⁾ ON 2

． 1 가 2
가 ．
가 ．
5 ， 8

5
6 Q-SW() 가 ．
가 Q-SW
가 ．

Table 7

. Photo 10

가

40sec

40sec

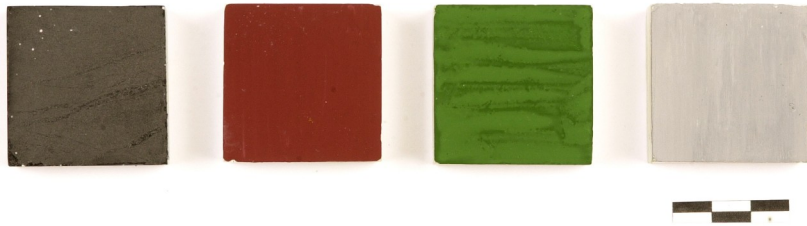


Photo 10.

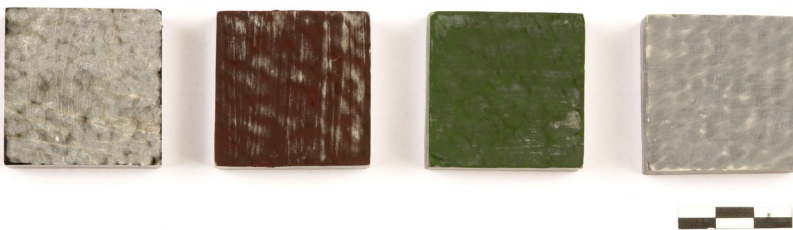


Photo 11.

. Photo 11

가

(Absorptivity)

100 %

가

가

가(假)

, Figure 39

(Focus)

(Focus in)

(Focus out)

(가)

Focusing

(Figure 39)

F=150

F=300

F=150

150mm

10mm

10

가

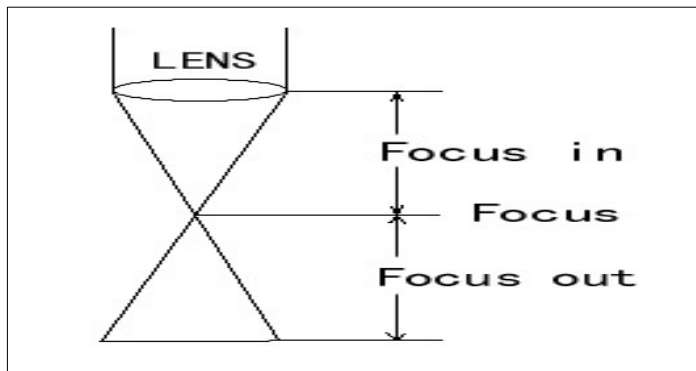


Figure 39.

Table 8.

TEST

:cm

	10	9	8	7	6	5	4	3	2	1	0	-1	-2	-3	-4	-5	-6	-7	-8	-9	-10
0.1	D	D	D	D	D	C	C	C	C	C	C	C	C	C	C	C	가 ()				
0.2	D	D	D	D	C	C	C	C	C	C	C	C	C	C	C	C					
0.3	D	D	D	C	A	A	A	A	A	B	B	B	C	C	A	A					
0.4	D	D	D	C	A	A	A	A	B	B	B	B	B	B	A	A					
0.5	D	D	D	C	A	A	A	B	B	B	B	B	B	B	B	A					

□ (:)

A. B. C. D.

Table 8 F=150 0() 5cm

가

0.3 0.5 가 가 .

0.1, 0.2

가 0.4

±5cm .

가 , , 가 , ,

. 가假

.

0.4 5cm 가

.

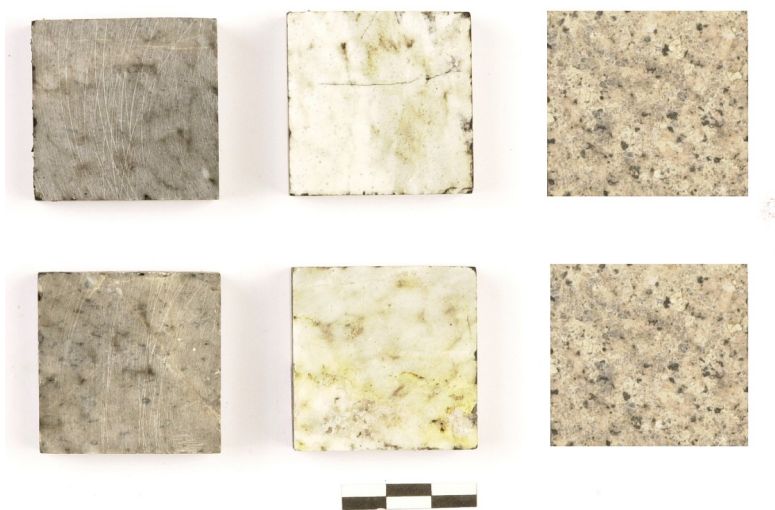


Photo 13.

가(假)

(가, ,)

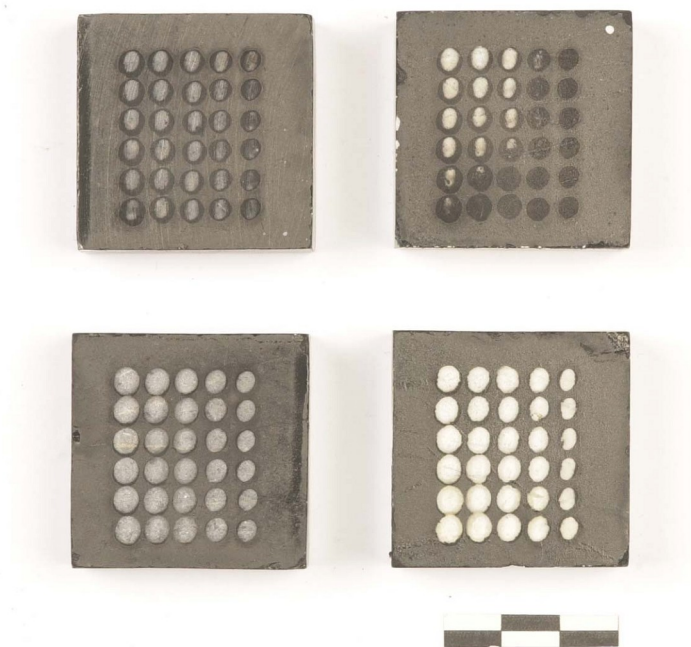


Photo 14.

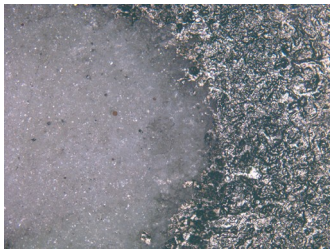
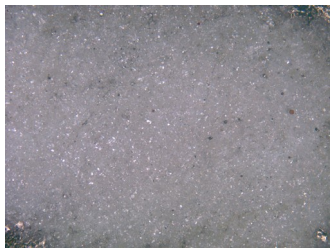
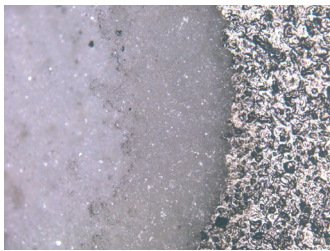
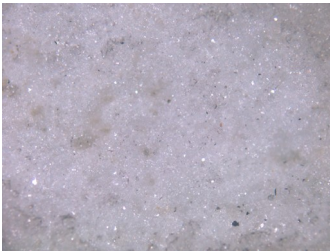
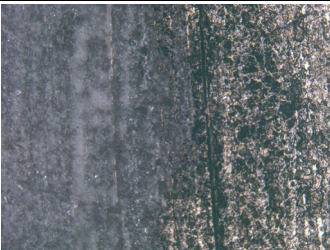
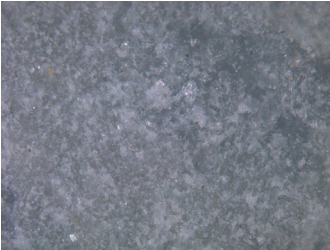
		
	A.2 (50X,)	B.2 (50X,)
		
	C.10 (50X,)	D.10 (50X,)
		
	E.2 (50X,)	F.2 (50X,)
		
	G.10 (50X,)	H.10 (50X,)

Figure 40.

(Photo 14)

Table 8. .

mm~ 1mm

0.5mm

1mm

0.5

POWER

가 0.1 0.5 5

가 0.4 (P.R.R) 4

SINGLE 2Hz, 5Hz, 10Hz

가 5Hz 가 가 .

Table 10. 20mm×20mm

	Q- SW	POWER	P.R.R	M/SEC
	○	0.4(4/5)	5Hz/5Level	1'19"
	○	0.4(4/5)	5Hz/5Level	1'6"
	○	0.4(4/5)	5Hz/5Level	36"
	×	0.4(4/5)	5Hz/5Level	-
	×	0.4(4/5)	5Hz/5Level	-
	×	0.4(4/5)	5Hz/5Level	-

Table 10 Q- SW ON/OFF
가 Q- SW가 OFF

. Q- SW ON
(20mm×20mm)
1mm 1 19 가
36 .

2)

가
가, , '가' , ' '
' ' . 40mm×40mm×20mm
()
(Photo 15). 가 ()
2 . (Sand Braster)
가 .
2~7bars (Glass beads) #90~150 (ø:0.16
~0.10mm, Eurogrit/) .

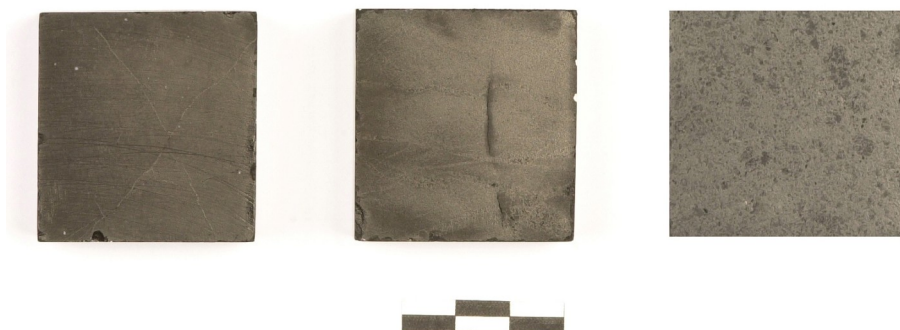


Photo 15.

(가, ,)



Photo 16.

(가, ,)

가

가

가

가

Photo 16 '가'

'가'

가
(Sand Paper)

가

7)

가 ,

. 가

.
가 . Photo 17, 19
가 .



Photo 17.



Photo 18.

Photo 18, 20
가 .

가

7	282	(高達寺址雙獅子石燈)	(京畿道)
(驪州郡)		(高達寺址) 1959	
		10	

가 ,
.



Photo 19.



Photo 20. 가

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1.

1990
가 1995 1994
·
· 1995 4
20 가 5 9
6 24 ·
· 6 () · 3
·
가 (8 , 148).
· 1995
1995 7
·
·
·
·
· 가
·
가 50%
·

Nd- YAG Las er Q- Switch
 (日本赤外線株式會社, Japan).
 가
 . Focusing⁸⁾
 가 .

2.

1)

1~3mm

가
 積債

가

가

가



Photo 21.



Photo 22.

가

Photo 21

가

가

가

가

Focusing

Focusing out

가

가

가

1~2

가

가

가



Photo 23.

가



Photo 24.

2)

가
가 ,
가 가 .
(Patina)⁹⁾
가 .

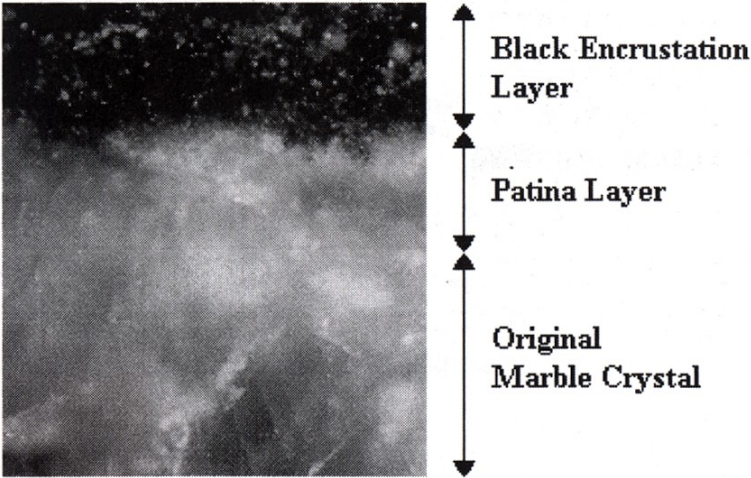


Photo 25.

Photo 25

9

Lee, J. M., and Watkins, *et al.*, 2001, Journal of Laser Application 13(1), pp19- 25

가

Photo 26, 27



Photo 26.



Photo 27.

가

가

가



Photo 28.

(3)

Photo 28

가 .

.

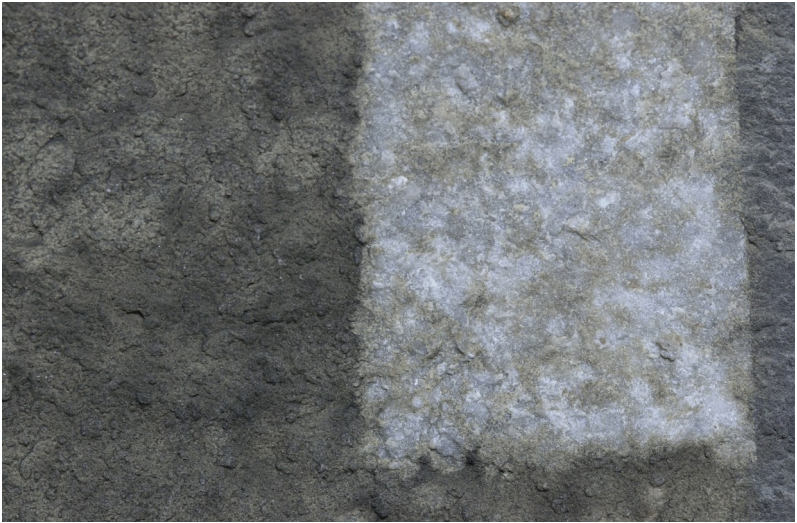


Photo 29.

Photo 29

가 .

. 가

가

가 .

가 , 가

가

가 .

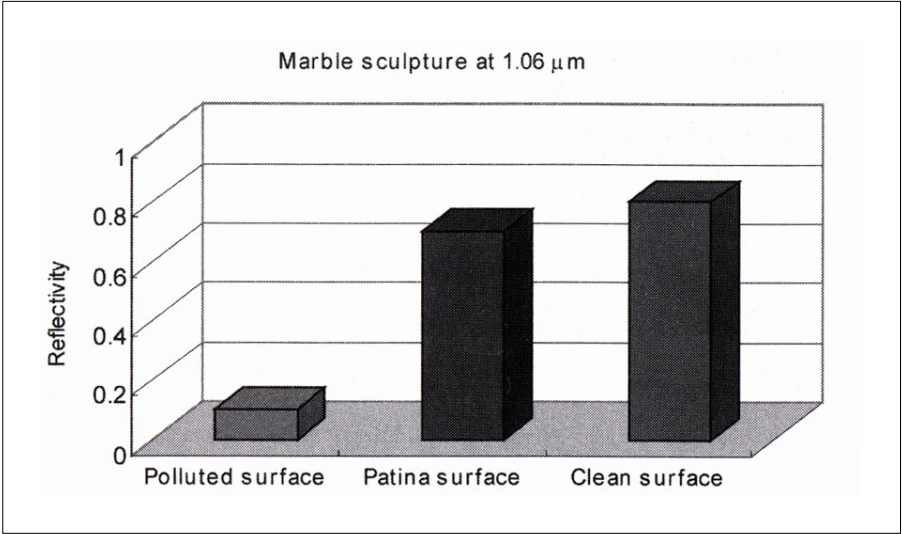


Figure 41.

Figure 41

1.06 μm Nd:YAG (Reflectivity)
 0.1, 0.7, 0.8

가 , 가 가
 가
 가 . ,
 ()

3)

(包)

(Photo 30).

가 가



Photo 30, 31, 31- 1.

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가

가

가

Photo 31

(刻字)

가

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가

가

가



Photo 32, 32- 1.

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가

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가 가

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가

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가

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가

.(Photo 35)

가

Nd:YAG

가 .

가

Nd:YAG

(excimer)

가

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가

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Photo 33, 34.



Photo 35.



Photo 36.

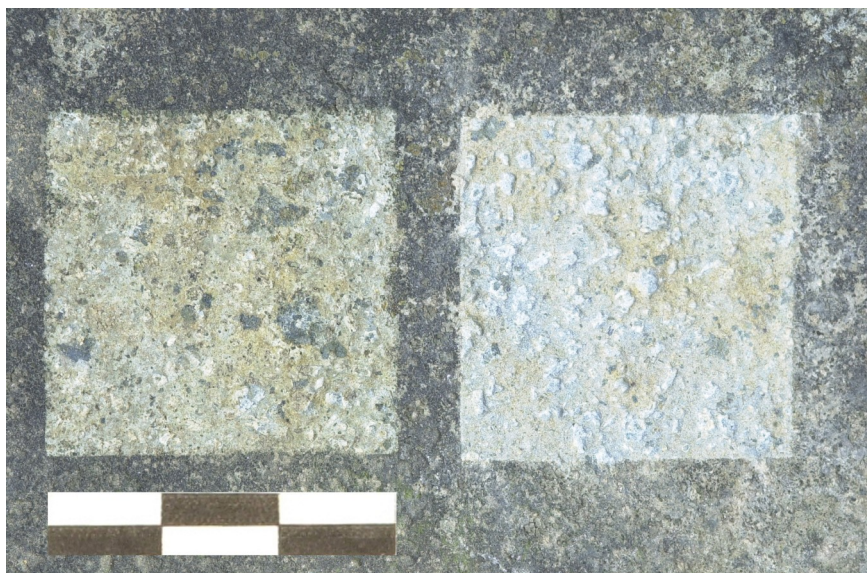


Photo 37. (- , -)

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_____, 『松都古蹟』,1946, 『松都古蹟』, ,1977.
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, 『 』, 6 (6), 1997.
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2001.
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<Abstract>

A study on elimination of contaminants used by the laser for the 10 storied-pagoda in the temple of Kyoungchunsa

Submitted by Kim Jinhyung

Department of Cultural Properties

Graduate School Gyeongju University

Supervised by Professor Han Gyongsoon

July 2003

It has been proved that pollutants stuck on surfaces of stone architecture have significant direct and indirect harmful effects on them, Among them some do not look evidently harmful, but they have potentials to ruin stone architecture as time goes on. Since the cultural assets have magnificent meanings as historical aspects, their future states should be considered seriously as well as the presence.

The past method to get rid of the pollutants from the surface of cultural properties has been changed a lot till the present along with scientific development of technology on this field. Existing method to eliminating pollutants are based on physical and chemical

processing, which can make damages on them too. Recently cleansing using LASER has been developed in Europe and proved as effective and relatively less harmful to remove pollutants, and it has been adopted widely.

After the success of the way by LASER, there are several trials to adopt the way to our cultural properties which have similar materials. Those showed satisfactory results and studies for developing the securer and more dependable ways to apply.

From now on the report will show the effective ways to apply the method using LASER on to the similar materials and different materials as well and discuss about the pros and cons about the method.